



Docket No. 0819-0559

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT application of)
Shin HASIMATO et al.) Attn: Application Branch
Serial No. 09/856,823)
Filed: May 25, 2001)
For: METHOD FOR FABRICATING)
SEMICONDUCTOR DEVICE)

REQUEST FOR CONSIDERATION OF DOCUMENTS CITED
IN INTERNATIONAL SEARCH REPORT

RECEIVED

OCT 23 2001

TC 1700

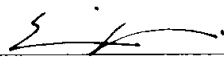
Honorable Commissioner for Patents
Washington, D.C. 20231

Sir:

It is requested, in accordance with the provisions of 37 CFR 1.56 and 37 CFR 1.97-1.99, that the references cited in the International Search Report dated December 19, 2000 (copy enclosed herewith) be considered and made of record in the subject application. These references are listed on the Form PTO-1449 submitted herewith.

Copies of the references are not submitted herewith inasmuch as copies of the references have been provided to the U.S. Patent and Trademark Office as indicated in the Notification of Acceptance dated July 3, 2001.

Respectfully submitted,


Eric J. Robinson
Registration No. 38,285

NIXON PEABODY LLP
8180 Greensboro Drive, Suite 800
McLean, Virginia 22102
(703) 790-9110